

Fig. 1

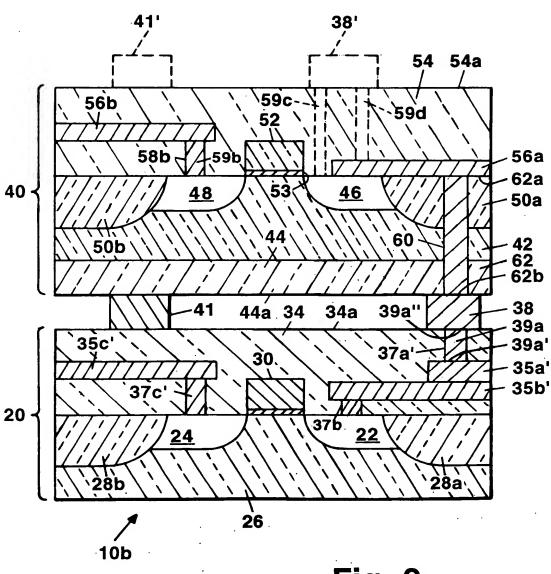
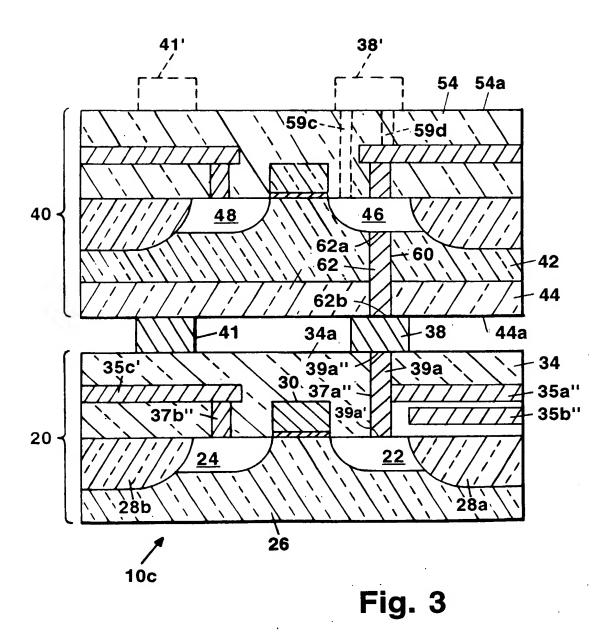


Fig. 2



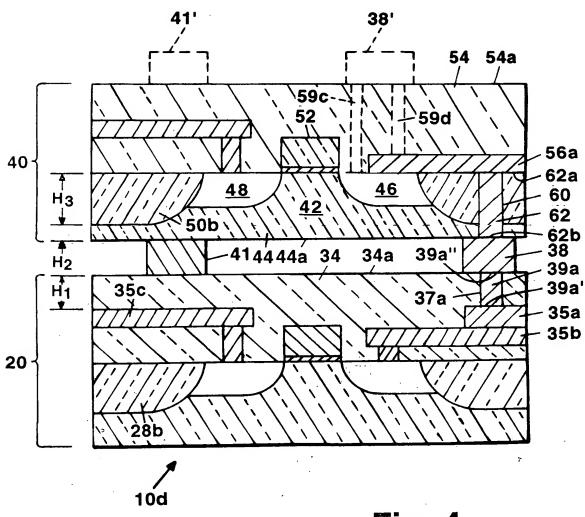


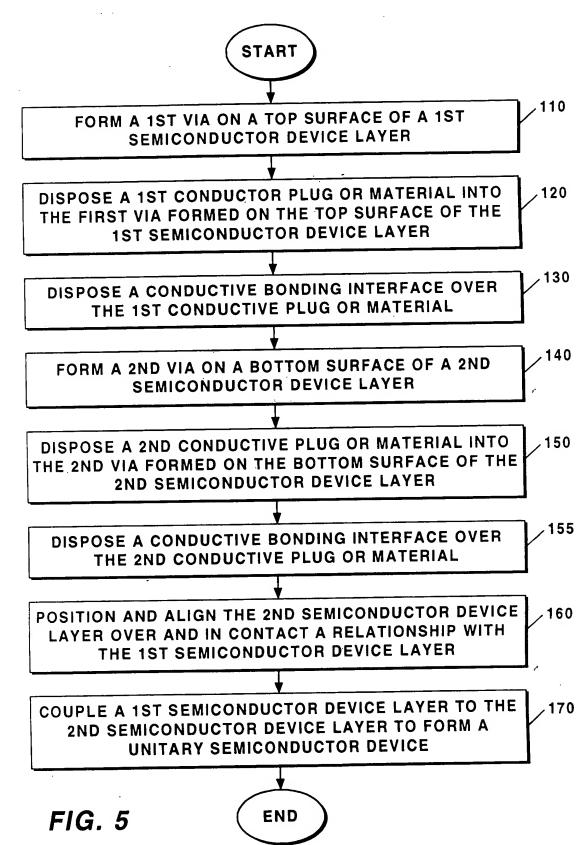
Fig. 4



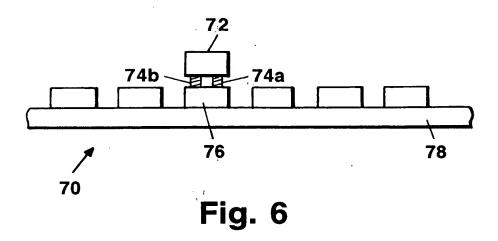
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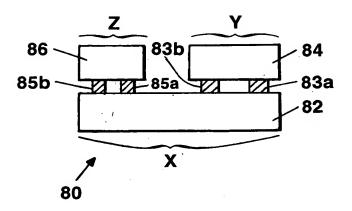


Fig. 7